Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

U.S. PATENT & TRADEMARK OFFICE MAR 0 9 2004

Docket Number (Optional)	Application Number
IME-03-010	10/742,120
Applicant: Chih Kiong Terence Gan et al.	
Filing Date: 12/19/03	Group Art Unit:

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DL	6563106	5/13/03	Bowers et al.	250	216	8/14/01
	6556737	4/29/03	Miu et al.	385	16	11/2/00
	6504643	1/7/03	Peeters et al.	359	290	9/28/00
	6480320	11/12/02	Nasiri	359	291	2/7/01
DL	6386716	5/14/02	Hagelin et al.	359	871	6/11/01

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DL — "Micromirrors for Adaptive-optics Arrays", by Michael A. Helmbrecht et al., Transducers '01 Eurosensors XV, June '01.

DL — "Three-dimensional structures obtained by double diffusion and electrochemical etch stop" by S. Marco et al., Jrnl of Micromech. Microeng. 3 (1993), pp. 141-142.

DL

EXAMINER	DATE CONSIDERED
DL	7/2005

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant